ATTY, DOCKET NO. SERIAL NO. FORMET 1449U.S. DEPARTMENT OF COMMERCE SJO9-2000-0043-US1 09/614,945 APPLICANT LIST OF PRIOR ART CITED BY APPLICANT KULA, W. (Use several sheets if necessary) FILING DATE **GROUP** 7/12/00 U.S. PATENT DOCUMENTS **EXAMINER** NAME **CLASS** SUBCLASS FILING DATE DATE DOCUMENT INITIAL NUMBER APPROPRIATE 692 428 6 7/14/98 Iwasaki et al. 9 2 428 611 12/15/98 Haywahi 3 332 4 6 9 5/7/96 Shinjo et al. 428 204 192.11 6 2/16/99 Pinarbasi 7/21/98 5 3 2 427 529 8 6 Chaiken et al. 切自 F ✓ 3 2 158 5 7 3 7/11/95 365 4 Kawano et al. G H FOREIGN PATENT DOCUMENTS DOCUMENT NUMBER DATE COUNTRY CLASS SUBCLASS **TRANSLATION** YES NO G11B 5/39 1 0 1/28/ Japan Ald 97 H01L 43/08 3 4 0 3 0 11/13 Japan /98 G11B 005/39 2/20/ Japan 0 4 9 8 3 98 G11B 005/39 9/13/ 8 2 3 5 5 4 0 Japan L / 96 OTHER PRIOR ART (Including Author, Title, Date, Pertinent Pages, Etc.) Lai, C et al., Anisotropic Exchange for NiFe Films Grown on Epitaxial NiO, IEEE Trans. Mag., vol. 31, no. 6, Nov 1995, pp; 2609-2611. Nakatani, R., et al., Magnetoresistive in Fe-Mn/Ni-Fe-Co/CO/Cu/Co/Ni-Fe-Co Sandwiches With NiO or NiO/Hf Buffer Layer, Mat. Trans, JIM, Vol. 37, No. 9, 1996, pp. 1458-1463. M N DATE CONSIDERED **EXAMINER** * EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

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